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AP/2800

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2877**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Katsura OTAKI

Group Art Unit: 2877

Application No.: 09/780,414

Examiner: S.A. Turner

Filed: February 12, 2001

Docket No.: 108598

For: **POINT DIFFRACTION INTERFEROMETER FOR MEASURING PROFILE  
IRREGULARITIES (AS AMENDED)**

**AMENDMENT AFTER FINAL REJECTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the June 11, 2003 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**

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